



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 24, 2026	
IGI Report Number	LG776682699
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.92 - 7.97 X 4.96 MM

GRADING RESULTS

Carat Weight	1.95 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

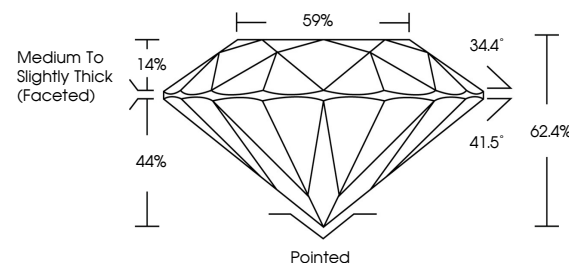
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG776682699

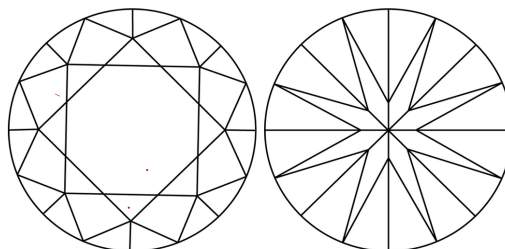
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG776682699
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

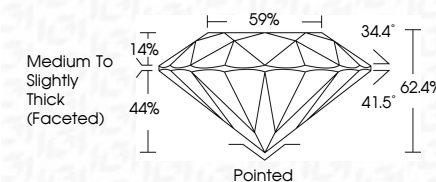
D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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www.igi.org

February 24, 2025	1.95 CARAT	
GI Report No. LG776682699	D	
ROUND BRILLIANT	VVS 2	
	IDEAL	
	62.4%	
	59%	
	Medium to slightly	
	Thick (feathered)	
	Polished	
	EXCELLENT	
	EXCELLENT	
	NONE	
	lg61 LG776682699	

Comments:

The Laboratory Grown Diamond was
 analyzed for Natural Vapor Deposition
 (NVD) growth process.
 type IIG